



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 3, 2026

IGI Report Number

LG821673661

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

6.58 - 6.63 X 3.93 MM

GRADING RESULTS

Carat Weight

1.04 CARAT

Color Grade

E

Clarity Grade

VVS 2

Cut Grade

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

VERY GOOD

Symmetry

VERY GOOD

Fluorescence

NONE

Inscription(s)

 LG821673661

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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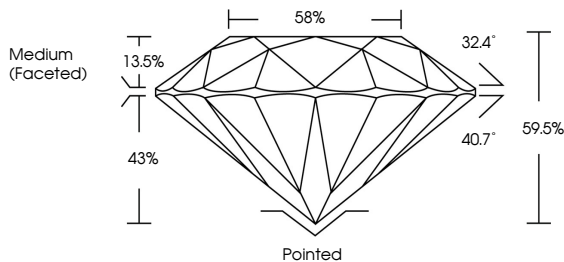
NONE

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PROPORTIONS



Medium (Faceted)

58%

32.4°

40.7°

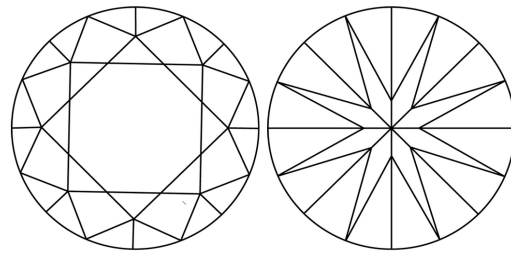
59.5%

43%

13.5%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

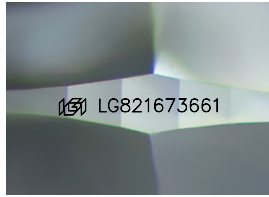
D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

Sample Image Used





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ROUND BRILLIANT

6.58 - 6.63 X 3.93 MM

Carat Weight

1.04 CARAT

Color Grade

E

Clarity Grade

VVS 2

Cut Grade

EXCELLENT

Depth

59.5%

Table

88%

Girdle

Medium (Faceted)

Culet

Pointed

Polish

VERY GOOD

Symmetry

VERY GOOD

Fluorescence

NONE

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